

Effects of Ar⁺ etching of Cu₂ZnSnSe₄ thin films : An x-ray photoelectron spectroscopy and photoluminescence study
Yakushev, Michael V.; Sulimov, Mikhail A.; Skidchenko, Ekaterina; **Krustok, Jüri** Journal of Vacuum Science & Technology B 2018 /
art. 061208, 8 p. : ill <https://doi.org/10.1116/1.5050243> [Journal metrics at Scopus](#) [Article at Scopus](#) [Journal metrics at WOS](#) [Article at WOS](#)